

Laterally Transported Quantum Structure Infrared Photodetector

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Wave Embedded Integrated Systems

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- Laterally transported QWIP (LQWIP, transistor type)
- Laterally transported QDIP (LQDIP, transistor type)



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Vertically transported QDIP (VQDIP)



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Vertically transported QDIP

Wave Embedded Integrated Systems

Structure of VQDIP

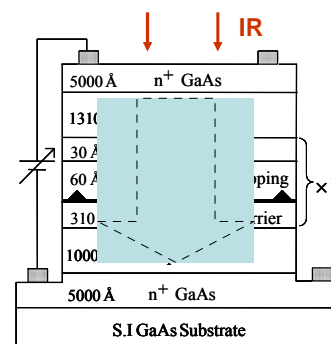


Figure of merit (FOM) of QSIP

- Responsivity (R)

$$R = \eta \frac{e}{h\nu} g \quad (A/W)$$

- Detectivity (D^*)

$$D^* = \frac{(A_d \Delta f)^{1/2}}{I_n} R \quad (\text{cm} \sqrt{\text{Hz}}/W)$$

$$g = \frac{\tau_{\text{life}}}{\tau_{\text{transit}}} \quad \eta \propto (1 - \exp(-\alpha L'))$$

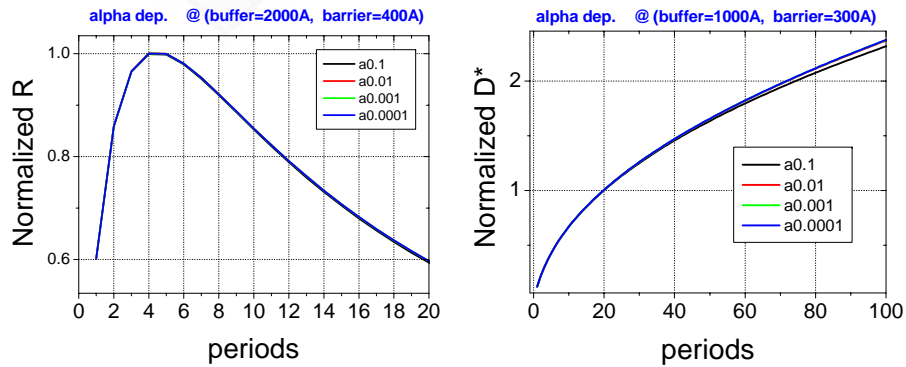
L' : absorption layer thickness

$N \uparrow \rightarrow \eta \uparrow \rightarrow \text{increase total device length} \rightarrow \tau_{\text{life}} \uparrow \rightarrow g \downarrow$



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Periods of QD layer vs. FOM



We can't increase responsivity and detectivity at the same time by increasing periods of QD layer

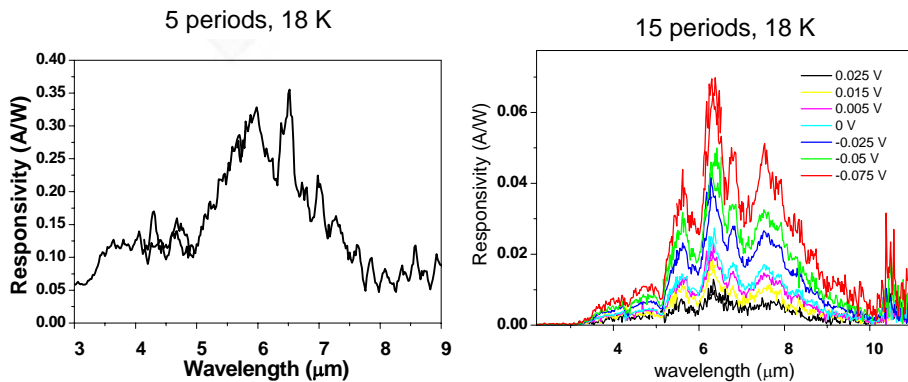
U.H. Lee, S. Hong, Journal of the Korean Physical Society Vol. 45, No. 2 pp.529



Laterally transported QWIP (LQWIP)



Example of VQDIP



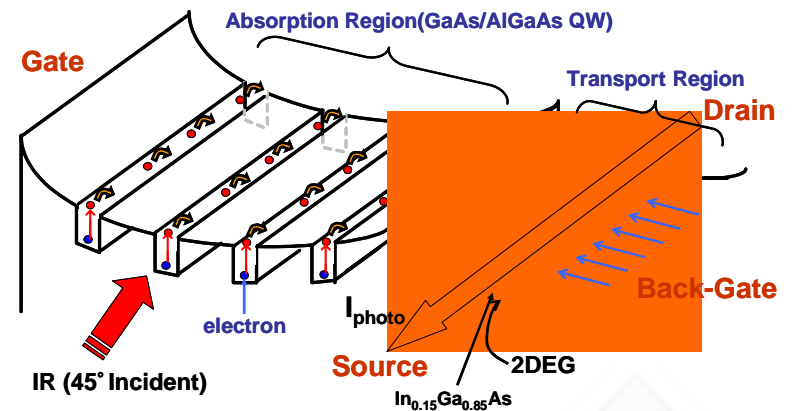
Responsivities of VQDIP (VQWIP) are under 1 A/W
How can we increase responsivity of QWIP or QDIP?

→Use transistor type QDIP! Laterally transported QWIP or QDIP



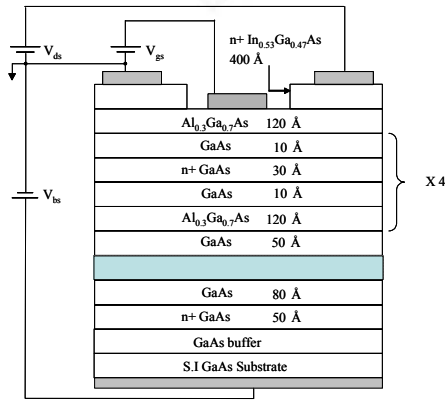
Laterally transported QWIP

L-QWIP Structure

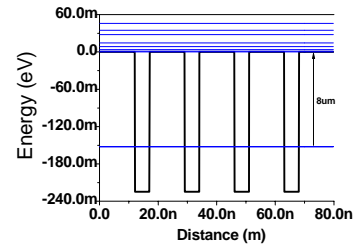


Laterally transported QWIP

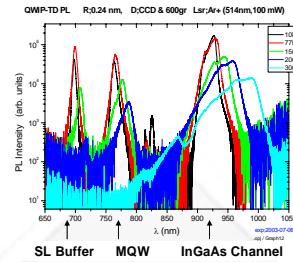
Epitaxial structure of LQWIP



Energy levels in QW layer

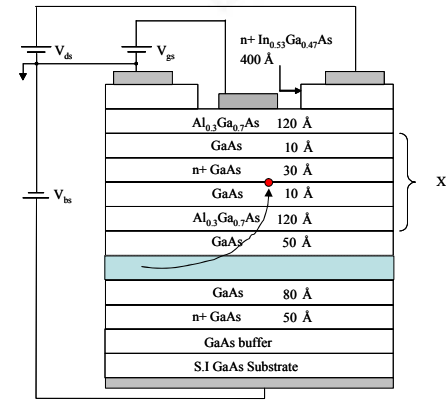


Photoluminescence (PL) of LQWIP

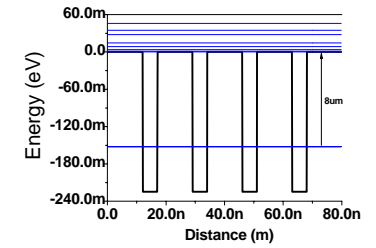


Laterally transported QWIP

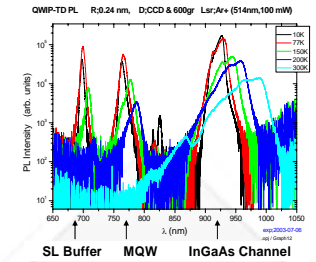
Epitaxial structure of LQWIP



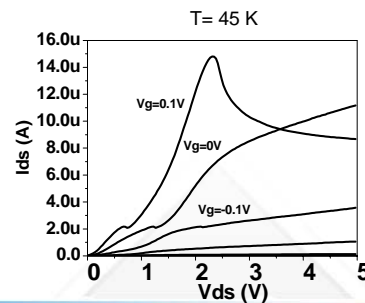
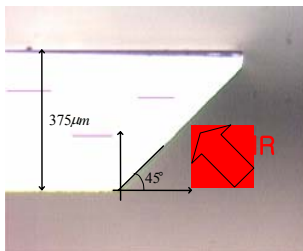
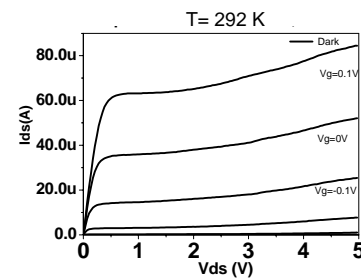
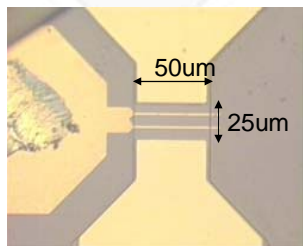
Energy levels in QW layer



Photoluminescence (PL) of LQWIP

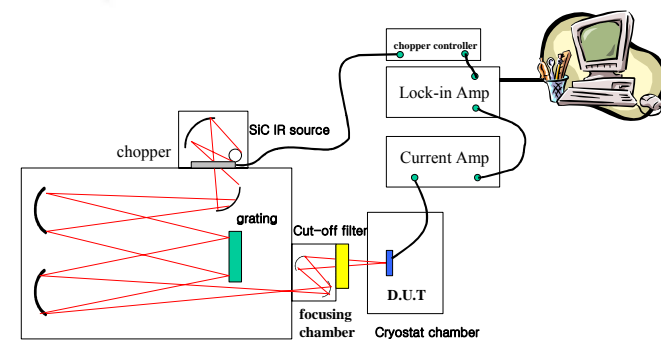


Laterally transported QWIP



Responsivity Spectrum Measurement

Responsivity Spectrum Measurement

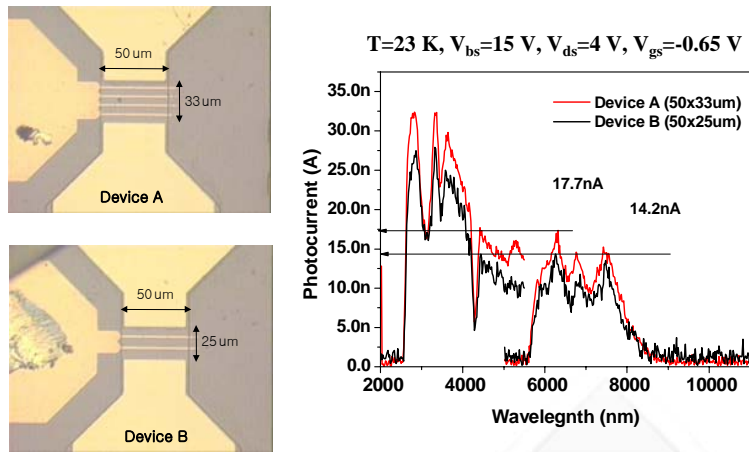


Standard MCT detector is used to calibrate responsivity spectrum
 Three optical long-wavelength pass filter (2.5 μm, 4 μm, 5.5 μm) is used

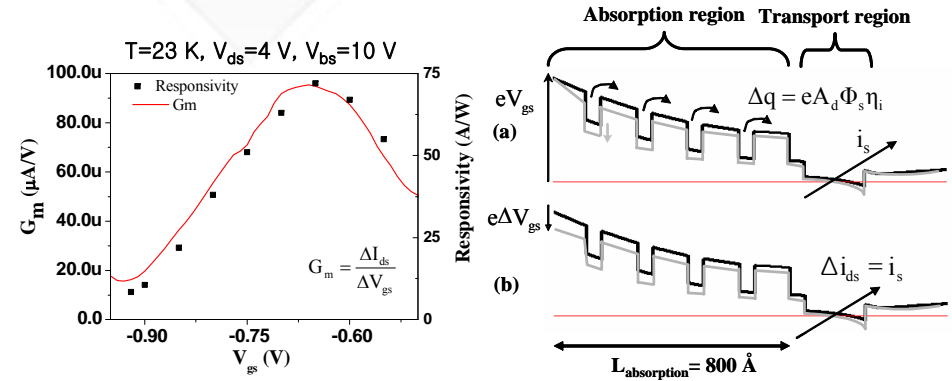


Laterally transported QWIP

Photocurrent Spectra (raw data) with different window area



Laterally transported QWIP



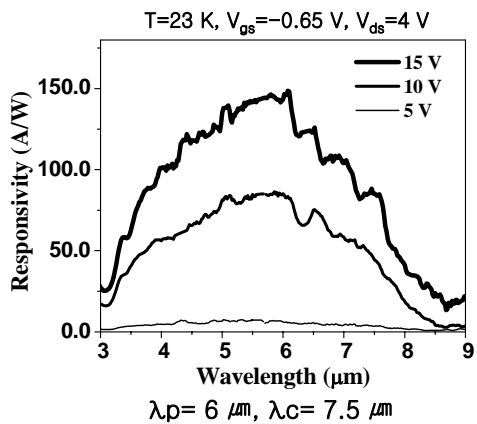
$$i_s = G_m \Delta V_{gs} \approx G_m \left(\frac{eA_d\Phi_s}{2\epsilon_s} \sum_i \eta_i \right) L_{\text{absorption}} = \frac{eA_d\Phi_s L_{\text{absorption}}}{2\epsilon_s} G_m \eta$$

$$R = \frac{i_s}{A_d\Phi_s h\nu} = \eta \frac{e}{h\nu} \frac{G_m L_{\text{absorption}}}{2\epsilon_s} = \eta \frac{e}{h\nu} g_{\text{LQWIP}} \Rightarrow \eta = 2.85\%, g_{\text{LQWIP}} = 474$$

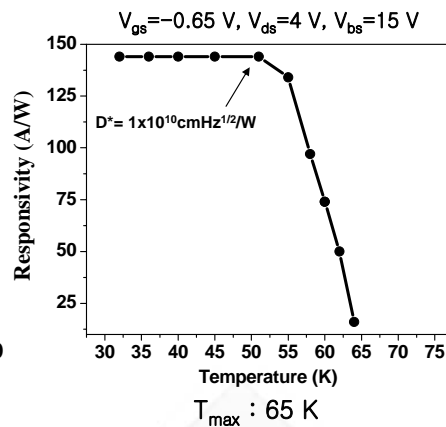


Laterally transported QWIP

Responsivity spectra with different V_{bs}



Peak responsivity at λ= 6 μm



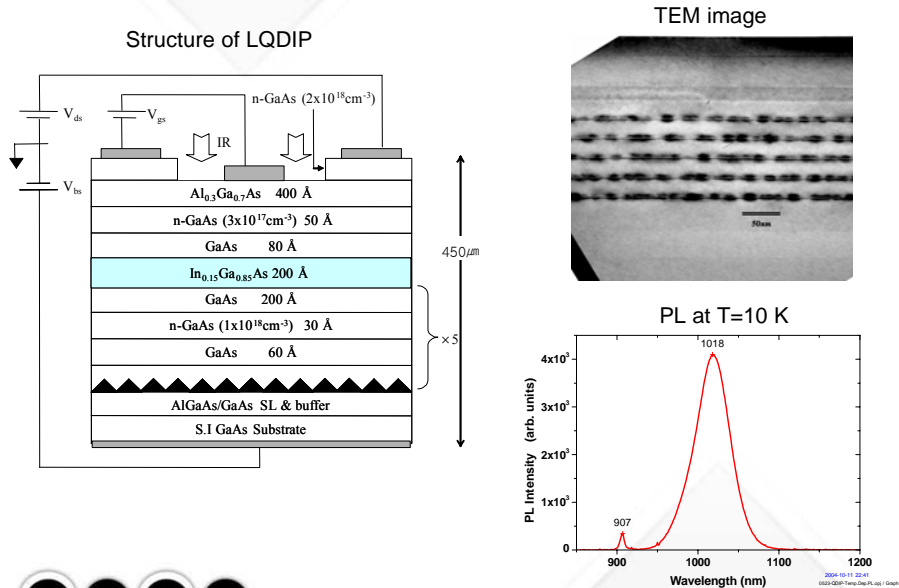
Maximum Responsivity of LQWIP ~ 140 A/W !!



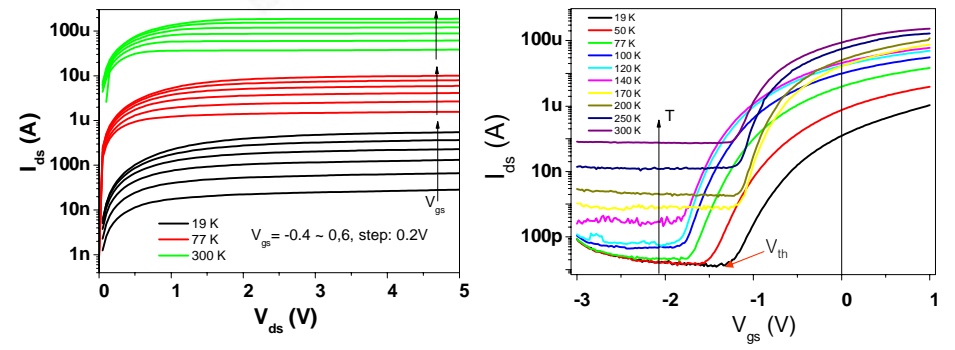
Laterally transported QDIP (LQDIP)



Laterally transported QDIP



Laterally transported QDIP

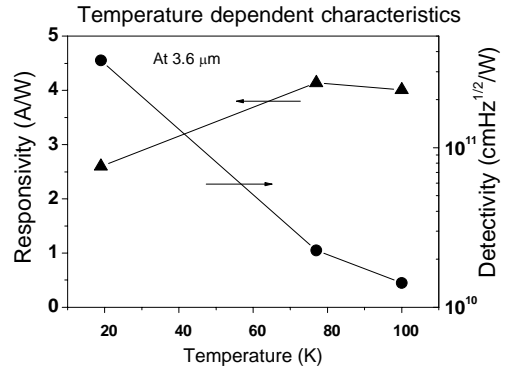
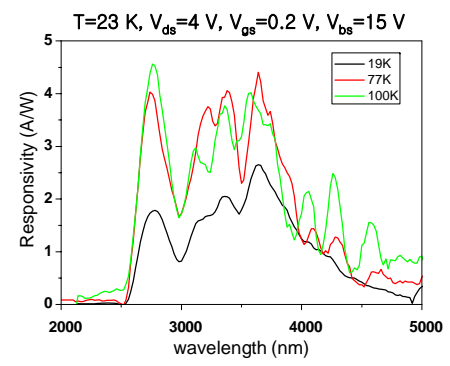


Threshold voltage (V_{th}) is changing as a function of temperature!



Laterally transported QDIP

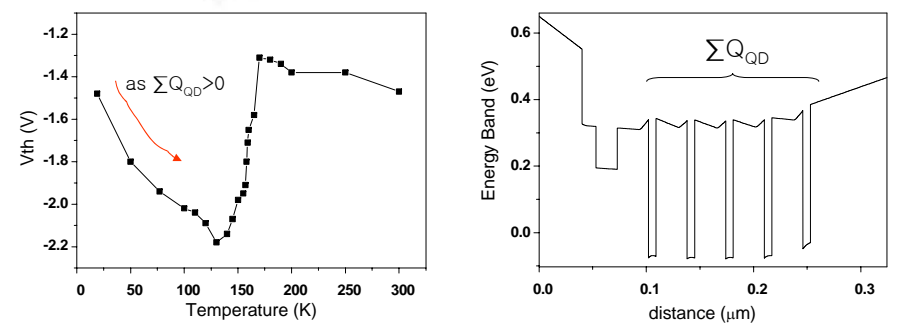
Spectral response



T=19 K, $\lambda_p = 3.6 \mu\text{m}$, $\lambda_c = 4 \mu\text{m}$, R=2.5 A/W, $D^* = 3 \times 10^{11} \text{cmHz}^{1/2}/\text{W}$
 T=100 K, $\lambda_p = 3.6 \mu\text{m}$, $\lambda_c = 4 \mu\text{m}$, R=4 A/W, $D^* = 1.4 \times 10^{10} \text{cmHz}^{1/2}/\text{W}$

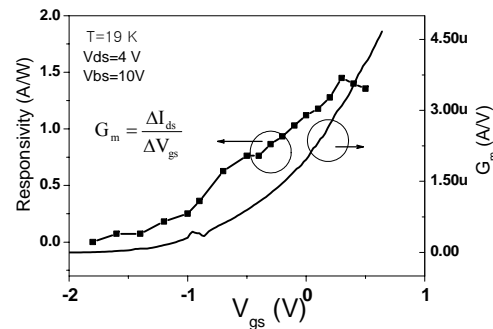
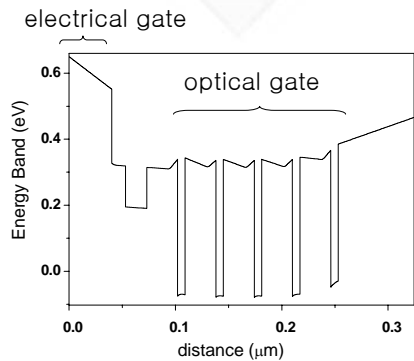
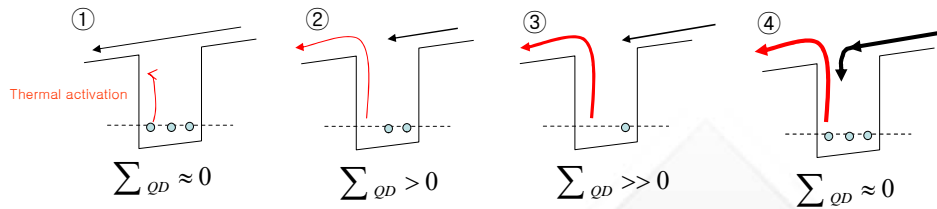
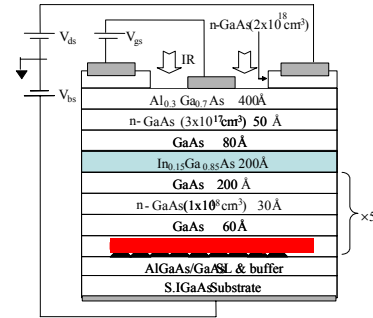
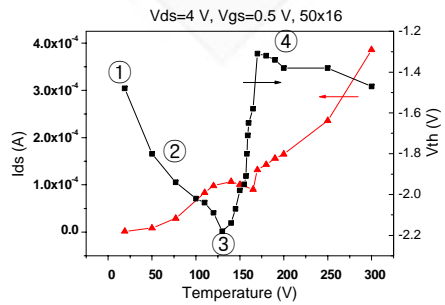


Laterally transported QDIP



V_{th} decreases if $\sum Q_{QD}$ becomes positive





When the light is incident, net charge of QD layers becomes positive by $eA_d\Phi_s\eta_i$

→ QD layers act as a optical gate

- Absorption layers (QD or QW) act as a optical gate in proposed LQSIP
- Responsivities of LQSIP are proportional to trans-conductance (G_m)
- Photocurrent of LQSIP can be switched by its gate voltage
- Maximum operation temperature (T_{max}) can be predicted from temperature dependent $I_{ds}-V_{gs}$ measurement